



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Group Art Unit: 2813
Examiner: Jack S. J. CHEN

In Re PATENT APPLICATION Of:

Applicants: Toshikazu MIZUKOSHI

Serial No.: 10/635,506

Filed: August 7, 2003

For: METHOD OF FABRICATING A
SEMICONDUCTOR DEVICE HAVING
TRENCHES

Docket No.: OKI 361

INFORMATION
DISCLOSURE
STATEMENT WITH
CERTIFICATION

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

This is an information disclosure statement submitted in compliance with the timing requirements of 37 C.F.R. §1.97(c), i.e., after a first Office Action on the merits but before Final Rejection and/or Notice of Allowance.

Attached is a copy of a Japanese patent publication. Also listed for consideration is one U.S. patent publication, which is the U.S. counterpart of the cited Japanese patent publication, and from which any relevance of the Japanese patent publication may be gleaned. The Japanese patent publication was first cited in a Japanese Office Action that was issued by the Japanese Patent Office in connection with a Japanese counterpart application. The publications are listed on the attached Form PTO-1449.

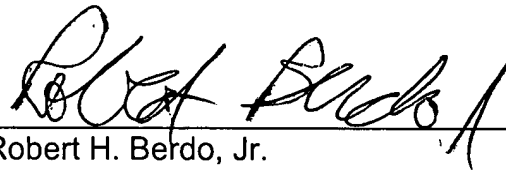
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It is hereby certified that each item of information contained in the Information Disclosure Statement was first cited in a communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

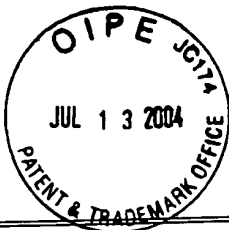
Consideration of the listed documents is respectfully requested.

Respectfully submitted,

July 13, 2004
Date


Robert H. Berdo, Jr.
Registration No. 38,075
RABIN & BERDO, P.C.
CUSTOMER NO. 23995
Telephone: (202)371-8976
Telefax: (202)408-0924

RHB:vm



FORM PTO-1449 INFORMATION DISCLOSURE STATEMENT				Atty. Docket OKI 361		Application No. 10/635,506	
				Applicant Toshikazu MIZUKOSHI			
				Filing Date August 7, 2003		Group 2813	
U.S. PATENT DOCUMENTS							
Examiner Initial		Document Number	Date	Name	Class	Sub-Class	Filing Date
	AA	US 6,242,323	06/05/01	Ishitsuka et al.			
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub-Class	Translation
	AI	JP 10-229119	08/25/98	JAPAN			
	AJ						
	AK						
	AL						
	AM						
	AN						
OTHER (Including Author, Title, Date, Pertinent Pages, etc.)							
	AO						
Examiner					Date Considered		
EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; draw line through citation if not in conformance and not considered. Include copy of this form with next communication to Applicant.							